

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/733,990	HAN ET AL.	
Examiner	Art Unit	
Khawar Inbal	2617	

	SEARCHED				
Class	Subclass	Date	Examiner		
455	69,522, 561,452.2, 67.11,424	9/7/2007	КІ		
370	252,278				
	329				

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
455	561	9/7/2007	КІ	
370	252			
see sear	ch history	·		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
John Pezzlo	8/27/2007	КІ		
QUOCHIEN VUONG	9/6/2007	KI		
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